

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Box: Patent Applications

Hirofumi FUKUOKA et al. :

Serial No.: Not Yet Assigned :

Filed: February 2, 2001 :



For: **METHOD AND APPARATUS FOR THE CONTINUOUS PRODUCTION OF SILICON OXIDE POWDER**

INFORMATION DISCLOSURE STATEMENT

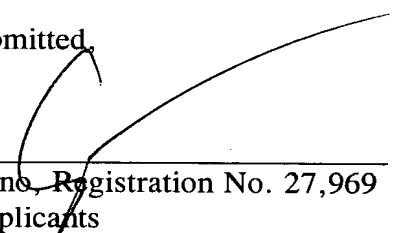
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicants wish to bring to the examiner's attention the references cited in the specification of the above-referenced application.

Applicants respectfully request the Examiner to confirm review of such documents by initialing and returning the attached PTO-1449.

Respectfully submitted,



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Form PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	ATTY. DKT. NO. KOJIM-366	SERIAL NO. Not Yet Assigned
	APPLICANT Hirofumi FUKUOKA et al.	
	FILING DATE February 2, 2001	GRANTED Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date
	AA					
	AB					
	AC					
	AD					
	AE					
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	AG					
	AH					
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	AJ					
	AK					
	AL					

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AM	9-110412	28APR97	Japan			
	AN	63-103815	09MAY88	Japan			
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	AU	English Abstract for Japan 9-110412
	AV	English Abstract for Japan 63-103815
	AW	
	AX	
	AY	
	AZ	
Examiner		Date Considered